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(54) **PHOTOACOUSTIC MEASUREMENT DEVICE AND PROBE**

FOTOAKUSTISCHE MESSVORRICHTUNG UND SONDE

DISPOSITIF ET SONDE DE MESURE PHOTOACOUSTIQUE

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Description

BACKGROUND OF THE INVENTION

1. Field of the Invention

[0001] The present invention relates to a photoacoustic measurement apparatus, more specifically, to a photoacoustic measurement apparatus for detecting photoacoustic waves generated in a subject after emitting light to the subject. In addition, the present invention relates to a probe used in such a photoacoustic measurement apparatus.

2. Description of the Related Art

[0002] As a kind of image examination method capable of examining the state of the inside of a living body in a non-invasive manner, an ultrasound examination method is known. In ultrasound examination, an ultrasound probe capable of transmitting and receiving ultrasound waves is used. In a case where ultrasound waves are transmitted from the ultrasound probe to the living body (subject), the ultrasound waves propagate through the living body to be reflected on the tissue interface. By receiving the reflected sound waves using the ultrasound probe and calculating the distance based on the time until the reflected ultrasound waves return to the ultrasound probe, it is possible to image the state of the inside.

[0003] In addition, photoacoustic imaging for imaging the inside of the living body using the photoacoustic effect is known. Generally, in photoacoustic imaging, pulsed laser light is emitted into the living body that is a subject. In the living body, a living tissue absorbs the energy of the pulsed laser light, and ultrasound waves (photoacoustic waves) are generated due to adiabatic expansion due to the energy. By detecting the photoacoustic waves using an ultrasound probe or the like and forming a photoacoustic image based on the detection signal, it is possible to visualize the inside of the living body based on the photoacoustic signal.

[0004] In the photoacoustic measurement, measurement is performed mainly in a state in which a probe is pressed against the surface of the subject. In a case where measurement light is emitted from the probe, strong photoacoustic waves are often generated in a surface portion of the subject on which the measurement light is incident. The main source of the photoacoustic waves is melanin of the skin surface. Photoacoustic waves generated in the surface portion of the subject travel near the surface or are multi-reflected, and accordingly the photoacoustic waves are detected by the probe together with a photoacoustic wave signal generated in a region of interest inside the subject. This is the cause of the occurrence of artifacts (virtual image).

[0005] In order to solve the aforementioned problem, in JP2013-55988A, first light and second light having different wavelengths are emitted to the subject, and a photoacoustic wave is detected for each of the first light and the second light. The wavelength of the first light and the wavelength of the second light are selected such that the ratio between the strength of a detection signal corresponding to a light absorber inside the subject due to the emission of the first light and the strength of a detection signal corresponding to the surface portion of the subject is smaller than the ratio between the strength of a detection signal corresponding to a light absorber inside the subject due to the emission of the second light and the strength of a detection signal corresponding to the surface portion of the subject. By reducing unnecessary signals generated in the surface portion of the subject by calculating the difference between a photoacoustic image obtained by the emission of the first light and a photoacoustic image obtained by the emission of the second light, it is possible to obtain an image with few artifacts.

[0006] US 2013/160557 A1 teaches a probe not having a correction light source as claimed.

SUMMARY OF THE INVENTION

[0007] In JP2013-55988A, however, in order to reduce artifacts, it is necessary to emit measurement light beams having two wavelengths and detect photoacoustic waves twice. That is, in order to obtain one photoacoustic image, it is necessary to emit two measurement light beams. Accordingly, there is a problem that the repetition period in the case of repeatedly generating a photoacoustic image is longer than that in a case where one photoacoustic image is obtained by emission of one measurement light. Usually, for measurement light used for photoacoustic measurement, high energy is required. Accordingly, since light sources for two wavelengths should be prepared as light sources for emitting such measurement light, there is also a problem that the cost increases.

[0008] In view of the above circumstances, it is an object of the present invention to provide a photoacoustic measurement apparatus capable of reducing artifacts due to photoacoustic waves generated in the surface portion of the subject even in a case where single measurement light is used. In addition, the present invention provides a probe used in such a photoacoustic measurement apparatus.

[0009] In order to achieve the aforementioned object, the present invention provides a probe comprising: a measurement light emitting unit that emits measurement light toward a subject; an acoustic wave detector that detects a photoacoustic wave generated within the subject due to the measurement light; a correction light source that emits correction light toward the subject; and a light intensity detector that detects reflected light generated by reflection of the correction light, which is emitted toward the subject, from the subject. The correction light source and the light intensity detector are disposed between the measurement light emitting unit and the acoustic wave detector.

[0010] In the present invention, it is preferable that the

measurement light emitting unit includes a light emission surface, which is a surface from which the measurement light is emitted, and the acoustic wave detector includes an acoustic wave detection surface, which is a surface on which the acoustic wave is incident, and that the correction light source and the light intensity detector are disposed within the same plane as the light emission surface and the acoustic wave detection surface.

[0011] The acoustic wave detector may include a plurality of detector elements arranged along one direction.

[0012] In the probe of the present invention, a plurality of the measurement light emitting units may be provided, and the plurality of measurement light emitting units may face each other with the acoustic wave detector interposed therebetween in a direction perpendicular to the arrangement direction of the detector elements. In this case, it is preferable that the correction light source and the light intensity detector are disposed between the measurement light emitting unit and the acoustic wave detector.

[0013] The correction light source may be configured to include a first correction light source, which is arranged along the arrangement direction of the detector elements and emits first correction light having a first wavelength, and a second correction light source, which is arranged along the arrangement direction of the detector elements and emits second correction light having a second wavelength different from the first wavelength.

[0014] In the above, the correction light source may include a plurality of the first correction light sources and a plurality of the second correction light sources. The plurality of first correction light sources and the plurality of second correction light sources may be alternately arranged along the arrangement direction of the detector elements.

[0015] The light intensity detector may be configured to include a first light intensity detector, which is arranged along the arrangement direction of the detector elements and selectively detects correction light having the first wavelength, and a second light intensity detector, which is arranged along the arrangement direction of the detector elements and selectively detects correction light having the second wavelength.

[0016] The first light intensity detector may include a first optical filter that transmits light having the first wavelength and does not transmit light having the second wavelength. The second light intensity detector may include a second optical filter that transmits light having the second wavelength and does not transmit light having the first wavelength.

[0017] The light intensity detector may include a plurality of the first light intensity detectors and a plurality of the second light intensity detectors. The plurality of first light intensity detectors and the plurality of second light intensity detectors may be alternately arranged along the arrangement direction of the detector elements.

[0018] A wavelength of the measurement light and a wavelength of the correction light may be different from

each other. In this case, the light intensity detector may further detect reflected light generated by reflection of the measurement light, which is emitted toward the subject, from the subject.

5 [0019] The correction light source may be configured to include a light emitting diode.

[0020] In addition, the present invention provides a photoacoustic measurement apparatus comprising: the above-described probe of the present invention; a light source that emits the measurement light; a signal processing device that has a signal processing unit that performs signal processing based on a detection signal of the photoacoustic wave detected by the acoustic wave detector, a melanin amount estimation unit that estimates an amount of melanin based on a detection signal of the reflected light detected by the light intensity detector, and a correction unit that corrects signal processing of the signal processing unit.

10 [0021] In the photoacoustic measurement apparatus of the present invention, it is preferable that the signal processing unit generates a photoacoustic image based on the detection signal of the photoacoustic wave.

[0022] In a case where the probe is configured to include a first correction light source and a second correction light source, the melanin amount estimation unit may estimate the amount of melanin based on a detection signal of reflected light of the first correction light detected by the light intensity detector and a detection signal of reflected light of the second correction light detected by the light intensity detector.

15 [0023] Alternatively, in a case where the probe is configured to further detect reflected light of the measurement light, the melanin amount estimation unit may estimate the amount of melanin based on a detection signal of reflected light of the correction light detected by the light intensity detector and a detection signal of reflected light of the measurement light detected by the light intensity detector.

[0024] The photoacoustic measurement apparatus and the probe of the present invention can measure photoacoustic waves even with single measurement light and can reduce artifacts due to photoacoustic waves generated in the surface portion of the subject.

45 BRIEF DESCRIPTION OF THE DRAWINGS

[0025]

50 Fig. 1 is a block diagram schematically showing a photoacoustic measurement apparatus including a probe according to a first embodiment of the present invention.

Fig. 2 is a plan view showing a probe.

Fig. 3 is a block diagram showing a signal processing device.

Fig. 4 is a flowchart showing the operation procedure of photoacoustic measurement.

Fig. 5 is a plan view showing a probe according to a

second embodiment of the present invention.

Fig. 6 is a plan view showing a probe according to a third embodiment of the present invention.

Fig. 7 is a flowchart showing the operation procedure of photoacoustic measurement in the third embodiment.

DESCRIPTION OF THE PREFERRED EMBODIMENTS

[0026] Hereinafter, embodiments of the present invention will be described in detail with reference to the diagrams. Fig. 1 shows the schematic configuration of a photoacoustic measurement apparatus including a probe according to a first embodiment of the present invention. The photoacoustic measurement apparatus includes a probe 10, an ultrasound unit (signal processing device) 20, and a light source 30.

[0027] The light source 30 emits measurement light. The measurement light emitted from the light source 30 is guided to the probe 10, for example, using light guide means, such as an optical fiber. The light source 30 is, for example, a solid state laser light source using an yttrium aluminum garnet (YAG), alexandrite, or the like. The wavelength of the measurement light is appropriately selected according to a measurement target. For example, a wavelength at which absorption in blood is stronger than that in the surrounding tissue, such as muscle fat, is selected. Hereinafter, an example in which light having a wavelength of 755 nm is mainly used as measurement light will be described. The type of the light source is not particularly limited, and the light source 30 may be a laser diode light source (semiconductor laser light source), or may be a light amplification type laser light source using a laser diode light source as a seed light source. Light sources other than the laser light source may be used.

[0028] The probe 10 has an acoustic wave detector 11, a measurement light emitting unit 12, a correction light source 13, and a light intensity detector 14. The measurement light emitting unit 12 emits measurement light, which is emitted from the light source 30, toward the subject. The acoustic wave detector 11 is an electroacoustic conversion unit that detects an acoustic wave and converts the detected acoustic wave into an electrical signal. The acoustic wave detector 11 detects photoacoustic waves generated within the subject due to the measurement light. The acoustic wave detector 11 includes, for example, a plurality of detector elements arranged along one direction. The detection signal of the acoustic wave detected by the acoustic wave detector 11 is transmitted to the signal processing device 20. The signal processing device 20 is a device that performs signal processing, and is typically a device having a processor, a memory, a bus, and the like.

[0029] The correction light source 13 emits correction light toward the subject. The correction light source 13 includes, for example, a light emitting diode. The energy of the correction light emitted from the correction light

source 13 may be lower than the energy of the measurement light emitted from the light source 30. The lighting of the correction light source 13 is controlled by the signal processing device 20, for example.

[0030] The light intensity detector 14 detects reflected light generated by the reflection of the correction light, which is emitted from the correction light source 13 toward the subject, from the subject. The light intensity detector 14 includes, for example, a photodiode. The detection signal of the reflected light detected by the light intensity detector 14 is transmitted to the signal processing device 20. The configuration of the light intensity detector 14 is not particularly limited as long as it is possible to output an electrical signal corresponding to incidence light.

[0031] The correction light source 13 and the light intensity detector 14 are disposed between the acoustic wave detector 11 and the measurement light emitting unit 12. The probe 10 may have a plurality of correction light sources 13 and a plurality of light intensity detectors 14. The plurality of correction light sources 13 and the plurality of light intensity detectors 14 may be arranged along the arrangement direction of detector elements in the acoustic wave detector 11.

[0032] The probe 10 may have a plurality of measurement light emitting units 12. The probe 10 has, for example, two measurement light emitting units 12. The plurality of measurement light emitting units 12 may be disposed so as to face each other with the acoustic wave detector 11 interposed therebetween in a direction perpendicular to the arrangement direction of the detector elements in the acoustic wave detector 11. In that case, the correction light source 13 and the light intensity detector 14 may be disposed between the acoustic wave detector 11 and the measurement light emitting unit 12.

[0033] Fig. 2 is a plan view of the probe 10 when viewed from the side in contact with a subject. The type of the probe 10 is not particularly limited, and a linear probe may be used, or a convex probe or a sector probe may be used. The acoustic wave detector 11 is disposed in a central portion of a housing (cover) forming the probe body. The longitudinal direction of the acoustic wave detector 11 matches the arrangement direction of the detector elements. In Fig. 2, the two measurement light emitting units 12 are disposed so as to face each other with the acoustic wave detector 11 interposed therebetween in a direction perpendicular to the longitudinal direction of the acoustic wave detector 11. In addition, the probe 10 has a plurality of light intensity detectors 14. The plurality of light intensity detectors 14 are arranged in a row along the longitudinal direction of the acoustic wave detector 11.

[0034] It is preferable that the correction light source 13 includes a plurality of light sources that emit correction light beams having a plurality of different wavelengths. In Fig. 2, the correction light source 13 includes a first correction light source 13a that emits first correction light having a first wavelength and a second correction light

source 13b that emits second correction light having a second wavelength. The first correction light source 13a emits, for example, light having a wavelength of 660 nm (first correction light) that is red light, and the second correction light source 13b emits, for example, light having a wavelength of 880 nm (second correction light) that is near infrared light.

[0035] The first correction light source 13a and the second correction light source 13b are arranged along the longitudinal direction of the acoustic wave detector 11. In Fig. 2, the correction light source 13 has a plurality of first correction light sources 13a and a plurality of second correction light sources 13b. The plurality of first correction light sources 13a and the plurality of second correction light sources 13b are alternately arranged along the longitudinal direction of the acoustic wave detector 11. The position of the correction light source 13 and the position of the light intensity detector 14 may be reversed.

[0036] The correction light source 13 and the light intensity detector 14 are disposed within the same plane as an acoustic wave incidence surface, which is a surface of the acoustic wave detector 11 on which an acoustic wave is incident, and a light emission surface, which is a surface of the measurement light emitting unit 12 from which measurement light is emitted. "Being disposed within the same plane" means that the correction light source 13, the light intensity detector 14, the acoustic wave incidence surface, and the light emission surface are present on a surface that is brought into contact with the subject when pressed against the subject. The side of the probe 10 in contact with the subject may be curved or inclined, or may have a slit, or may have a step difference. Also in such a case, it is assumed that the correction light source 13 and the light intensity detector 14 are present within the same plane as the acoustic wave detection surface and the light emission surface. The arrangement of the respective elements shown in Fig. 2 is an example, and the number of elements, the shape of each element, and the positional relationship between elements are not limited thereto.

[0037] Fig. 3 shows the signal processing device 20. The signal processing device 20 has a receiving circuit 21, a receiving memory 22, a signal processing unit 23, a melanin amount estimation unit 24, a correction unit 25, and a light source control unit 26.

[0038] The receiving circuit 21 receives a detection signal output from the acoustic wave detector 11 of the probe 10, and stores the received detection signal in the receiving memory 22. Typically, the receiving circuit 21 includes a low noise amplifier, a variable gain amplifier, a low pass filter, and an analog to digital converter (AD converter). The detection signal of the acoustic wave detector 11 is amplified by the low noise amplifier, and then gain adjustment according to the depth is performed by the variable gain amplifier and a high-frequency component is cut by the low pass filter. Then, conversion into a digital signal is performed by the AD converter, and the digital signal is stored in the receiving memory 22. The receiving

circuit 21 is formed by one integrated circuit (1C), for example. As the receiving memory 22, for example, a semiconductor memory is used.

[0039] The acoustic wave detector 11 outputs a detection signal of the photoacoustic wave, and the detection signal (sampling data) of the photoacoustic wave after AD conversion is stored in the receiving memory 22. The signal processing unit 23 reads the detection signal of the photoacoustic wave from the receiving memory 22, and performs signal processing on the read detection signal of the photoacoustic wave. The signal processing unit 23 generates a photoacoustic image based on the detection signal of the photoacoustic wave, for example. The generation of a photoacoustic image includes, for example, image reconstruction such as phase matching addition, detection, and logarithmic conversion. The generated photoacoustic image is displayed on an image display device 40. The signal processing unit 23 is formed by large scale integration (LSI), such as a digital signal processor (DSP). The function of the signal processing unit 23 may be realized by software processing using a processor included in the signal processing device 20.

[0040] The melanin amount estimation unit 24 estimates the amount of melanin of the surface of the subject based on the detection signal of the reflected light with respect to the correction light output from the light intensity detector 14. It is known that melanin exhibits a spectrum in which the light absorption characteristic in the visible to near infrared region monotonously decreases with an increasing wavelength and that the spectral intensity in the entire wavelength region increases as the amount of melanin increases. The amount of melanin can be estimated based on the intensity of reflected light of light beams having a plurality of wavelengths. In order to estimate the amount of melanin using reflected light beams having a plurality of wavelengths, it is possible to use a known method.

[0041] The melanin amount estimation unit 24 estimates the amount of melanin based on the detection signal of the reflected light in a case where the first correction light source 13a (refer to Fig. 2) is lit and the detection signal of the reflected light in a case where the second correction light source 13b is lit. As in the example shown in Fig. 2, in a case where a plurality of light intensity detectors 14 are arranged along the longitudinal direction of the acoustic wave detector 11, the amount of melanin may be estimated at each position in the longitudinal direction. The melanin amount estimation unit 24 may estimate a degree indicating whether the amount of melanin of the surface of the subject is large or small, and it is not necessary to accurately quantify the amount of melanin. Emission of correction light and detection of reflected light may be performed multiple times, and the amount of melanin may be estimated using an average value, a median value, or the like of the detection signals of the plurality of reflected light beams.

[0042] The correction unit 25 corrects the signal processing of the signal processing unit 23 based on the

amount of melanin estimated by the melanin amount estimation unit 24. The correction is performed, for example, by changing the brightness of the surface portion of the subject in the photoacoustic image generated by the signal processing unit 23 according to the estimated amount of melanin. For example, the correction unit 25 corrects the photoacoustic image by lowering the brightness of the surface portion of the subject as the estimated amount of melanin increases. In this case, since the brightness of the surface portion is lowered, it becomes easy to observe the inside of the subject.

[0043] The correction unit 25 may correct the photoacoustic image by changing the brightness of the entire photoacoustic image according to the estimated amount of melanin. More specifically, the gain of the photoacoustic image may increase as the estimated amount of melanin increases. In that case, since the brightness of the surface portion is saturated while the inner portion is drawn brightly, it becomes easy to observe the inside of the subject.

[0044] The correction unit 25 may change the brightness according to the estimated amount of melanin and the position or depth of the photoacoustic image. More specifically, the brightness of the deep portion of the image may be lowered as the estimated amount of melanin increases. If the amount of melanin is large, photoacoustic waves generated in the surface portion of the subject become strong. The photoacoustic waves cause multiple reflections to increase artifacts. By lowering the brightness of the deep portion, it is possible to obtain an image in which the influence of artifacts is reduced. Instead of the above, the brightness of the surface portion may be lowered, and the brightness of the deep portion of the image may be increased. In that case, it is possible to obtain an image easy to see (image easy to observe) by making the brightness of the entire image uniform.

[0045] Each of the melanin amount estimation unit 24 and the correction unit 25 may be formed by large scale integration (LSI), such as a digital signal processor (DSP), for example. Alternatively, these functions may be realized by software processing using a processor included in the signal processing device 20. The correction unit 25 may be a part of the signal processing unit 23.

[0046] Estimation of the amount of melanin by the melanin amount estimation unit 24 is performed before the signal processing unit 23 performs signal processing or after the signal processing is performed. In a case where the estimation of the amount of melanin is performed before the signal processing, the signal processing unit 23 may perform signal processing according to the content of the correction of the correction unit 25. In a case where the estimation of the amount of melanin is performed after the signal processing, the correction unit 25 may correct the result of the signal processing of the signal processing unit 23.

[0047] The light source control unit 26 controls the light source 30 and the correction light source 13. For example, in the case of acquiring a photoacoustic image, the

light source control unit 26 transmits an optical trigger signal to the light source 30 so that measurement light is emitted from the light source 30. The light source control unit 26 may control the photoacoustic wave sampling start timing or the like by transmitting a sampling trigger signal to the receiving circuit 21 in response to the emission of the measurement light. The area where photoacoustic waves are to be detected may be divided into a plurality of areas. In that case, emission of light to the subject and detection of photoacoustic waves may be performed for each area.

[0048] In the case of estimating the amount of melanin, the light source control unit 26 causes correction light to be emitted from the correction light source 13. In a case where the correction light source 13 has light sources that emit correction light beams having a plurality of wavelengths, the light source control unit 26 causes the correction light beams to be selectively emitted from these. For example, in a case where the correction light source 13 has a first correction light source 13a and a second correction light source 13b as shown in Fig. 2, the correction light beams are selectively emitted from these. The light source control unit 26 is formed by a programmable logic device (PLD), such as a field-programmable gate array (FPGA), for example.

[0049] Hereinafter, the operation procedure will be described. Fig. 4 shows a procedure of photoacoustic measurement. A doctor or the like presses the probe 10 against an examination part of the subject. The light source control unit 26 turns on the first correction light source 13a to emit the first correction light to the subject (step A1). The light intensity detector 14 detects reflected light of the first correction light, and transmits the detection signal to the signal processing device 20 (step A2).

[0050] Then, the light source control unit 26 turns on the second correction light source 13b to emit the second correction light to the subject (step A3). The light intensity detector 14 detects the reflected light of the second correction light, and transmits the detection signal to the signal processing device 20 (step A4). Either the emission of the first correction light or the emission of the second correction light may be performed first. The melanin amount estimation unit 24 estimates the amount of melanin of a portion, against which the probe 10 is pressed, based on the detection signal of the reflected light of the first correction light and the detection signal of the reflected light of the second correction light that have been received from the light intensity detector 14 (step A5).

[0051] Then, the light source control unit 26 causes the light source 30 to emit measurement light (step A6). The acoustic wave detector 11 detects photoacoustic waves generated within the subject due to the emission of the measurement light (step A7). The detection signal of the photoacoustic wave is input to the signal processing unit 23 through the receiving circuit 21 and the receiving memory 22. The signal processing unit 23 performs signal processing on the detection signal of the

photoacoustic wave (step A8). The signal processing unit 23 generates a photoacoustic image, for example. The correction unit 25 corrects the signal processing of the signal processing unit 23, for example, image generation processing, according to the amount of melanin estimated in step A5 (step A9).

[0052] In the present embodiment, the correction light source 13 and the light intensity detector 14 are provided in the probe. The reflected light of the correction light emitted from the correction light source 13 is detected by the light intensity detector 14, the amount of melanin is estimated based on the detection signal of the reflected light, and signal processing on the detection signal of the photoacoustic wave is corrected. The photoacoustic wave generated in the surface portion of the subject is generated mainly due to melanin present in the surface portion of the subject. By correcting the signal processing on the photoacoustic wave according to the estimated amount of melanin, it is possible to reduce artifacts due to the photoacoustic wave generated in the surface portion of the subject. In the present embodiment, unlike in JP2013-55988A, it is not necessary to emit a plurality of measurement light beams in one photoacoustic measurement. Therefore, it is possible to reduce artifacts due to the photoacoustic wave generated in the surface portion of the subject without extending the repetition period in the case of repeatedly performing photoacoustic measurement.

[0053] In the present embodiment, the correction light source 13 and the light intensity detector 14 are disposed between the acoustic wave detector 11 and the measurement light emitting unit 12. By adopting such an arrangement, it is possible to estimate the amount of melanin in the vicinity of the acoustic wave detector 11 and the measurement light emitting unit 12. In addition, by arranging a plurality of correction light sources 13 (the first correction light source 13a and the second correction light source 13b) and the light intensity detectors 14 along the longitudinal direction of the acoustic wave detector 11 as shown in Fig. 2, data of the estimated amount of melanin can be obtained as one-dimensional distribution data. In this case, correction according to the position within the plane becomes possible.

[0054] In the case of a configuration in which the measurement light emitting unit 12 is provided in the probe 10, photoacoustic waves may be generated by absorption of a part of measurement light by the housing that forms the probe body in the vicinity of the measurement light emitting unit 12. The photoacoustic wave is transmitted through the surface portion of the housing and is detected by the acoustic wave detector 11, which may cause artifacts. In the present embodiment, since the correction light source 13 and the light intensity detector 14 are present between the acoustic wave detector 11 and the measurement light emitting unit 12, an interface having different acoustic impedance is formed between the acoustic wave detector 11 and the measurement light emitting unit 12. Therefore, it can be expected that pho-

toacoustic waves generated in the vicinity of the measurement light emitting unit 12 are reflected and scattered at the interface. As a result, since it is difficult for the photoacoustic waves generated in the vicinity of the measurement light emitting unit 12 to be incident on the acoustic wave detector 11, it is possible to reduce artifacts caused by the photoacoustic waves.

[0055] Subsequently, a second embodiment of the present invention will be described. Fig. 5 shows a probe according to the second embodiment of the present invention. The present embodiment is different from the first embodiment in that the light intensity detector 14 disposed in a probe 10a includes a plurality of light intensity detectors that selectively detect correction light beams having a plurality of wavelengths. Others may be the same as in the first embodiment.

[0056] The light intensity detector 14 includes a first light intensity detector 14a that selectively detects reflected light of the first correction light and a second light intensity detector 14b that selectively detects reflected light of the second correction light. The first light intensity detector 14a and the second light intensity detector 14b are arranged along the longitudinal direction of the acoustic wave detector 11. In Fig. 5, the light intensity detector 14 has a plurality of first light intensity detectors 14a and a plurality of second light intensity detectors 14b. The plurality of first light intensity detectors 14a and the plurality of second light intensity detectors 14b are alternately arranged along the longitudinal direction of the acoustic wave detector 11.

[0057] The first light intensity detector 14a includes an optical filter that transmits light having a first wavelength and does not transmit light having a second wavelength, for example. That is, the first light intensity detector 14a includes a first optical filter that transmits the first correction light and does not transmit the second correction light. The second light intensity detector 14b includes an optical filter that transmits the light having the second wavelength and does not transmit the light having the first wavelength, for example. That is, the second light intensity detector 14b includes an optical filter that transmits the second correction light and does not transmit the first correction light. By using such an optical filter, it is possible to selectively detect the first correction light or the second correction light.

[0058] For example, in a case where the wavelength of the first correction light is 660 nm and the wavelength of the second correction light is 880 nm, the first light intensity detector 14a includes an optical filter that transmits light having a wavelength of 660 nm and does not transmit light having a wavelength of 880 nm. As such an optical filter, a band pass filter in which a wavelength of 660 nm is included in the transmission band and 880 nm is not included in the transmission band, a short pass filter that transmits only light having a wavelength equal to or less than a wavelength shorter than the wavelength of 880 nm and longer than the wavelength of 660 nm, or the like can be considered. The second light intensity

detector 14b includes an optical filter that transmits light having a wavelength of 880 nm and does not transmit light having a wavelength of 660 nm. As such an optical filter, a band pass filter in which a wavelength of 880 nm is included in the transmission band and 660 nm is not included in the transmission band, a long pass filter that transmits only light having a wavelength equal to or greater than a wavelength longer than the wavelength of 660 nm and shorter than the wavelength of 880 nm, or the like can be considered. In this explanation, it is needless to say that "transmit" or "does not transmit" includes a case of "transmit" or "does not transmit" most of light.

[0059] In the present embodiment, the light intensity detector 14 disposed in the probe 10a includes a plurality of light intensity detectors that selectively detect reflected light of a plurality of correction light beams having different wavelengths. For example, the first light intensity detector 14a does not detect the reflected light of the second correction light, and the second light intensity detector 14b does not detect the reflected light of the first correction light. In the case of using the probe 10a having such a configuration, it is possible to simultaneously emit a plurality of correction light beams from the correction light source 13. For example, it is possible to simultaneously emit the first correction light and the second correction light and to simultaneously detect the reflected light beams. In this manner, there is an effect that the time required to estimate the amount of melanin can be shortened. Other effects are the same as in the first embodiment.

[0060] Subsequently, a third embodiment of the present invention will be described. Fig. 6 shows a probe according to the third embodiment of the present invention. The present embodiment is different from the first embodiment in that the light intensity detector 14 disposed in a probe 10b detects the reflected light of measurement light emitted from the measurement light emitting unit 12 in addition to detecting the reflected light of correction light emitted from the correction light source 13. In the present embodiment, the wavelength of measurement light emitted from the light source 30 (Fig. 1) is different from the wavelength of the correction light emitted from the correction light source 13. Others may be the same as in the first embodiment.

[0061] Fig. 7 shows the operation procedure of photoacoustic measurement in the present embodiment. A doctor or the like presses the probe 10b against an examination part of the subject. The light source control unit 26 (refer to Fig. 3) turns on the correction light source 13 to emit correction light to the subject (step B1). The light intensity detector 14 detects the reflected light of the correction light, and transmits the detection signal to the signal processing device 20 (step B2).

[0062] Then, the light source control unit 26 causes the light source 30 (refer to Fig. 1) to emit measurement light (step B3). The acoustic wave detector 11 detects photoacoustic waves generated within the subject due to the emission of the measurement light (step B4). The

detection signal of the photoacoustic wave is input to the signal processing unit 23 through the receiving circuit 21 and the receiving memory 22. The signal processing unit 23 performs signal processing on the detection signal of the photoacoustic wave (step B5). The signal processing unit 23 generates a photoacoustic image, for example.

[0063] On the other hand, the light intensity detector 14 detects the reflected light of the measurement light emitted in step B3, and transmits the detection signal to the signal processing device 20 (step B6). The melanin amount estimation unit 24 estimates the amount of melanin of a portion, against which the probe 10b is pressed, based on the detection signal of the reflected light of the correction light and the detection signal of the reflected light of the measurement light that have been received from the light intensity detector 14 (step B7). In a case where there is a large level difference between the detection signal of the reflected light of the correction light and the detection signal of the reflected light of the measurement light, the melanin amount estimation unit 24 may estimate the amount of melanin after correcting the level difference.

[0064] The correction unit 25 corrects the signal processing of the signal processing unit 23, for example, image generation, according to the amount of melanin estimated in step B7 (step B8). The correction may be the same as that described in the first embodiment.

[0065] In the present embodiment, the light intensity detector 14 detects the reflected light of the measurement light emitted from the measurement light emitting unit 12 in addition to the reflected light of the correction light emitted from the correction light source 13. In the present embodiment, one wavelength among a plurality of wavelengths used in estimating the amount of melanin is obtained from the measurement light for photoacoustic measurement. In such a case, the correction light source 13 does not need to emit correction light beams having a plurality of wavelengths. Therefore, it is possible to reduce the number of types (wavelengths) of correction light source that need to be disposed in the probe 10b. In addition, in a case where the detection of photoacoustic waves and the detection of reflected light are performed in parallel, there is an effect that the time required to estimate the amount of melanin can be shortened. Other effects are the same as in the first embodiment.

[0066] Although the emission of measurement light and the detection of photoacoustic waves are performed after estimating the amount of melanin in Fig. 4, the timing of the emission of measurement light and the detection of photoacoustic waves are not particularly limited. The emission of measurement light and the detection of photoacoustic waves may be performed before the emission of the first correction light, or the emission of measurement light and the detection of photoacoustic waves may be performed between the emission of the first correction light and the emission of the second correction light. The signal processing on the detection signal of the photoacoustic wave (step A8) and the correction according to

the estimated amount of melanin (step A9) do not need to be separated, and the signal processing in step A8 may be performed according to the correction content in step A9.

[0067] In addition, although the emission of measurement light, detection of photoacoustic waves, and detection of reflected light are performed after the emission of correction light and detection of reflected light in Fig. 7, the order is not particularly limited. The measurement light may be emitted first and the detection of photoacoustic waves and the detection of the reflected light of the measurement light may be performed, and then correction light may be emitted and the reflected light may be detected. In the same manner as described above, the signal processing on the detection signal of the photoacoustic wave (step B5) and the correction according to the estimated amount of melanin (step B8) do not need to be separated, and the signal processing in step B5 may be performed according to the correction content in step B8.

[0068] In Fig. 7, the detection of photoacoustic waves (step B4) and the detection of reflected light (step B6) are performed in parallel after emitting the measurement light in step B3, the present invention is not necessarily limited thereto. Either the detection of photoacoustic waves or the detection of reflected light may be performed every emission of measurement light. Usually, the repetition frequency of the light source 30 used for photoacoustic measurement is about 10 Hz to 30 Hz. Accordingly, from the viewpoint of shortening the repetition period of photoacoustic measurement, it is advantageous to output no separate measurement light for detecting the reflected light.

[0069] The relationship between the estimation of the amount of melanin and the detection of photoacoustic waves may not be a one-to-one relationship. For example, means capable of detecting the movement of the probe 10 may be provided, and the amount of melanin may be estimated by performing the emission of correction light and the detection of reflected light in a case where the movement of the probe 10 is detected. In a case where there is no movement of the probe 10, correction according to the amount of melanin estimated at that position may be applied to signal processing on the detection signal of the photoacoustic wave that is performed multiple times.

[0070] Although the amount of melanin is estimated mainly based on the reflected light beams having two wavelengths, the amount of melanin may be corrected based on the reflected light beams having three or more wavelengths. For example, the correction light source 13 may include light sources that emit correction light beams having three or more wavelengths, the light intensity detector 14 may detect reflected light beams of the correction light beams having three or more wavelengths, and the melanin amount estimation unit 24 may estimate the amount of melanin based on the detection signal of the reflected light beams of the correction light beams having

three or more wavelengths. By increasing the number of wavelengths of reflected light used for estimation, it is possible to improve the accuracy of melanin amount estimation.

[0071] The respective embodiments described above can be appropriately used in combination. For example, the first and third embodiments may be combined, so that the light intensity detector 14 detects the reflected light of the first correction light, the reflected light of the second correction light, and the reflected light of the measurement light and the melanin amount estimation unit 24 estimates the amount of melanin based on the detection signal of the reflected light. In addition, the second and third embodiments may be combined, so that the light intensity detector 14 is configured to include a light intensity detector that selectively detects the reflected light of the first correction light, a light intensity detector that selectively detects the reflected light of the second correction light, and a light intensity detector that selectively detects the reflected light of the measurement light.

[0072] While the present invention has been described based on the preferred embodiments, the photoacoustic measurement apparatus and the probe of the present invention are not limited to the above embodiments, and various modifications and changes in the configurations of the above embodiments are also included in the range of the present invention.

Explanation of References

[0073]

- 10: probe
- 11: acoustic wave detector
- 12: measurement light emitting unit
- 13: correction light source
- 14: light intensity detector
- 20: signal processing device
- 21: receiving circuit
- 22: receiving memory
- 23: signal processing unit
- 24: melanin amount estimation unit
- 25: correction unit
- 26: light source control unit
- 30: light source
- 40: image display device

Claims

1. A probe, comprising:

- a measurement light emitting unit configured to emit measurement light toward a subject;
- an acoustic wave detector configured to detect a photoacoustic wave generated within the subject due to the measurement light;
- a correction light source configured to emit cor-

- rection light toward the subject; and
a light intensity detector configured to detect reflected light generated by reflection of the correction light, which is emitted toward the subject, from the subject,
wherein the correction light source and the light intensity detector are disposed between the measurement light emitting unit and the acoustic wave detector.
2. The probe according to claim 1,
wherein the measurement light emitting unit includes a light emission surface, which is a surface from which the measurement light is emitted, and the acoustic wave detector includes an acoustic wave detection surface, which is a surface on which the acoustic wave is incident, and
the correction light source and the light intensity detector are disposed within the same plane as the light emission surface and the acoustic wave detection surface.
 3. The probe according to claim 1 or 2,
wherein the acoustic wave detector includes a plurality of detector elements arranged along one direction.
 4. The probe according to claim 3,
wherein a plurality of the measurement light emitting units are provided, and the plurality of measurement light emitting units face each other with the acoustic wave detector interposed therebetween in a direction perpendicular to the one direction, and
the correction light source and the light intensity detector are disposed between the measurement light emitting unit and the acoustic wave detector.
 5. The probe according to claim 3 or 4,
wherein the correction light source includes a first correction light source, which is arranged along the one direction and configured to emit first correction light having a first wavelength, and a second correction light source, which is arranged along the one direction and emits second correction light having a second wavelength different from the first wavelength.
 6. The probe according to claim 5,
wherein the correction light source includes a plurality of the first correction light sources and a plurality of the second correction light sources.
 7. The probe according to claim 6,
wherein the plurality of first correction light sources and the plurality of second correction light sources are alternately arranged along the one direction.
 8. The probe according to any one of claims 3 to 7,
wherein the light intensity detector includes a first light intensity detector, which is arranged along the one direction and configured to selectively detect correction light having the first wavelength, and a second light intensity detector, which is arranged along the one direction and configured to selectively detect correction light having the second wavelength.
 9. The probe according to claim 8,
wherein the first light intensity detector includes a first optical filter configured to transmit light having the first wavelength and to does not transmit light having the second wavelength, and
the second light intensity detector includes a second optical filter configured to transmit light having the second wavelength and to not transmit light having the first wavelength.
 10. The probe according to claim 8 or 9,
wherein the light intensity detector includes a plurality of the first light intensity detectors and a plurality of the second light intensity detectors.
 11. The probe according to claim 10,
wherein the plurality of first light intensity detectors and the plurality of second light intensity detectors are alternately arranged along the one direction.
 12. The probe according to any one of claims 1 to 11,
wherein a wavelength of the measurement light and a wavelength of the correction light are different from each other, and
the light intensity detector further being configured to detect reflected light generated by reflection of the measurement light, which is emitted toward the subject, from the subject.
 13. The probe according to any one of claims 1 to 12,
wherein the correction light source includes a light emitting diode.
 14. A photoacoustic measurement apparatus, comprising:
the probe according to any one of claims 1 to 13;
a light source configured to emit the measurement light; and
a signal processing device that has a signal processing unit configured to perform signal processing based on a detection signal of the photoacoustic wave detected by the acoustic wave detector, a melanin amount estimation unit that estimates an amount of melanin based on a detection signal of the reflected light detected by the light intensity detector, and a correction unit configured to correct signal processing of the signal processing unit.

15. The photoacoustic measurement apparatus according to claim 14,
wherein the signal processing unit is configured to generate a photoacoustic image based on the detection signal of the photoacoustic wave.
16. The photoacoustic measurement apparatus according to claim 14 or 15,
wherein the probe is the probe according to any one of claims 5 to 11, and
the melanin amount estimation unit is configured to estimate the amount of melanin based on a detection signal of reflected light of the first correction light detected by the light intensity detector and a detection signal of reflected light of the second correction light detected by the light intensity detector.
17. The photoacoustic measurement apparatus according to any one of claims 14 to 15,
wherein the probe is the probe according to claim 12, and
the melanin amount estimation unit is configured to estimate the amount of melanin based on a detection signal of reflected light of the correction light detected by the light intensity detector and a detection signal of reflected light of the measurement light detected by the light intensity detector.

Patentansprüche

1. Sonde, umfassend:

eine Messlicht-Emissionseinheit, konfiguriert zum Emittieren von Messlicht auf ein Subjekt;
ein Akustikwellendetektor, konfiguriert zum Detektieren einer fotoakustischen Welle, die in dem Subjekt aufgrund des Messlichts erzeugt wird;
eine Korrekturlichtquelle, konfiguriert zum Emittieren von Korrekturlicht auf das Subjekt; und
einen Lichtintensitätsdetektor, konfiguriert zum Detektieren reflektierten Lichts, das erzeugt wird durch Reflexion des auf das Subjekt emittierten Korrekturlichts an dem Subjekt,
wobei die Korrekturlichtquelle und der Lichtintensitätsdetektor zwischen der Messlicht-Emissionseinheit und dem Akustikwellendetektor angeordnet sind.

2. Sonde nach Anspruch 1,
bei der die Messlicht-Emissionseinheit eine Lichtemissionsfläche enthält, das ist eine Fläche, von welcher das Messlicht emittiert wird, und der Akustikwellendetektor eine Akustikwellen-Detektorfläche enthält, das ist eine Fläche, an der die Akustikwelle auftrifft, und
die Korrekturlichtquelle und der Lichtintensitätsde-

tektor innerhalb der gleichen Ebene angeordnet sind wie die Lichtemissionsfläche und die Akustikwellen-Detektorfläche.

3. Sonde nach Anspruch 1 oder 2,
bei der der Akustikwellendetektor mehrere Detektorelemente enthält, die entlang einer Richtung angeordnet sind.
4. Sonde nach Anspruch 3, bei der mehrere der Messlicht-Emissionseinheiten vorgesehen sind, und die mehreren Messlicht-Emissionseinheiten einander mit dazwischen liegendem Akustikwellendetektor in einer Richtung rechtwinklig zu der genannten einen Richtung gegenüberliegen, und
die Korrekturlichtquelle und der Lichtintensitätsdetektor zwischen der Messlicht-Emissionseinheit und dem Akustikwellendetektor angeordnet sind.
5. Sonde nach Anspruch 3 oder 4,
bei der die Korrekturlichtquelle eine erste Korrekturlichtquelle, die entlang der einen Richtung angeordnet und konfiguriert ist zum Emittieren ersten Korrekturlichts mit einer ersten Wellenlänge, und eine zweite Korrekturlichtquelle enthält, die entlang der einen Richtung angeordnet ist und zweites Korrekturlicht mit einer zweiten, von der ersten Wellenlänge verschiedenen Wellenlänge emittiert.
6. Sonde nach Anspruch 5, bei der die Korrekturlichtquelle mehrere von den ersten Korrekturlichtquellen und mehrere von den zweiten Korrekturlichtquellen enthält.
7. Sonde nach Anspruch 6, bei der die mehreren ersten Korrekturlichtquellen und die mehreren zweiten Korrekturlichtquellen abwechselnd entlang der einen Richtung angeordnet sind.
8. Sonde nach einem der Ansprüche 3 bis 7,
bei der der Lichtintensitätsdetektor einen ersten Lichtintensitätsdetektor, der entlang der einen Richtung angeordnet und konfiguriert ist zum selektiven Detektieren von Korrekturlicht mit der ersten Wellenlänge, und einen zweiten Lichtintensitätsdetektor enthält, der entlang der einen Richtung angeordnet und konfiguriert ist zum selektiven Detektieren von Korrekturlicht mit der zweiten Wellenlänge.
9. Sonde nach Anspruch 8, bei der der erste Lichtintensitätsdetektor ein erstes optisches Filter, konfiguriert ist zum Durchlassen von Licht mit der ersten Wellenlänge und zum Nicht-Durchlassen von Licht mit der zweiten Wellenlänge enthält, und
der zweite Lichtintensitätsdetektor ein zweites optisches Filter enthält, konfiguriert zum Durchlassen von Licht mit der zweiten Wellenlänge und zum Nicht-Durchlassen von Licht mit der ersten Wellen-

länge.

10. Sonde nach Anspruch 8 oder 9, bei der der Lichtintensitätsdetektor mehrere von den ersten Lichtintensitätsdetektoren und mehrere von den zweiten Lichtintensitätsdetektoren enthält. 5
11. Sonde nach Anspruch 10, bei der die mehreren ersten Lichtintensitätsdetektoren und die mehreren zweiten Lichtintensitätsdetektoren abwechselnd entlang der einen Richtung angeordnet sind. 10
12. Sonde nach einem der Ansprüche 1 bis 11, bei der eine Wellenlänge des Messlichts und eine Wellenlänge des Korrekturlichts voneinander verschieden sind, und der Lichtintensitätsdetektor weiterhin konfiguriert ist zum Detektieren reflektierten Lichts, das erzeugt wird durch Reflexion des auf das Subjekt emittierten Messlichts an dem Subjekt. 15 20
13. Sonde nach einem der Ansprüche 1 bis 12, bei der die Korrekturlichtquelle eine Leuchtdiode enthält. 25
14. Fotoakustische Messvorrichtung, umfassend:
 - die Sonde nach einem der Ansprüche 1 bis 13; eine Lichtquelle, konfiguriert zum Emittieren des Messlichts; und 30
 - eine Signalverarbeitungseinrichtung mit einer Signalverarbeitungseinheit, konfiguriert zum Ausführen einer Signalverarbeitung basierend auf einem Detektorsignal der fotoakustischen Welle, welche von dem Akustikwellendetektor detektiert wird, eine Melaninmengen-Abschätz- 35
 - einheit, die eine Melaninmenge basierend auf einem Detektorsignal des reflektierten Lichts abschätzt, welches von dem Lichtintensitätsdetektor detektiert wird, und eine Korrektur- 40
 - einheit, konfiguriert zum Korrigieren der Signalverarbeitung durch die Signalverarbeitungseinheit.
15. Vorrichtung nach Anspruch 14, bei der die Signalverarbeitungseinheit konfiguriert ist zum Erzeugen eines fotoakustischen Bilds basierend auf dem Detektorsignal der fotoakustischen Welle. 45
16. Vorrichtung nach Anspruch 14 oder 15, bei der die Sonde eine Sonde nach einem der Ansprüche 5 bis 11 ist, und 50
- die Melaninmengen-Abschätzeinheit konfiguriert ist zum Abschätzen der Melaninmenge basierend auf einem detektorsignalreflektierten Lichts des ersten Korrekturlichts, das von dem Lichtintensitätsdetektor detektiert wird, und basierend auf einem detektorsignalreflektierten Lichts des zweiten Korrektur- 55
- lichts, das von dem Lichtintensitätsdetektor detek-

tiert wird.

17. Vorrichtung nach einem der Ansprüche 14 bis 15, bei der die Sonde die Sonde nach Anspruch 12 ist, und 5
- die Melaninmengen-Abschätzeinheit konfiguriert ist zum Abschätzen der Melaninmenge basierend auf einem detektorsignalreflektierten Lichts des Korrekturlichts, das von dem Lichtintensitätsdetektor detektiert wird, und einem detektorsignalreflektierten Lichts des Messlichts, das von dem Lichtintensitätsdetektor detektiert wird.

Revendications

1. Sonde, comprenant :

- une unité émettant une lumière de mesure, configurée pour émettre une lumière de mesure vers un sujet ;
- un détecteur d'onde acoustique, configuré pour détecter une onde photoacoustique générée dans le sujet suite à la lumière de mesure ;
- une source de lumière de correction, configurée pour émettre une lumière de correction vers le sujet, et
- un détecteur d'intensité lumineuse, configuré pour détecter une lumière réfléchie, générée par la réflexion de la lumière de correction, laquelle est émise vers le sujet, à partir du sujet, dans laquelle la source de lumière de correction et le détecteur d'intensité lumineuse sont disposés entre l'unité émettant une lumière de mesure et le détecteur d'onde acoustique.

2. Sonde selon la revendication 1, dans laquelle l'unité émettant une lumière de mesure inclut une surface d'émission lumineuse, laquelle est une surface à partir de laquelle la lumière de mesure est émise, et le détecteur d'onde acoustique inclut une surface de détection d'onde acoustique, laquelle est une surface sur laquelle l'onde acoustique est incidente, et 45
- la source de lumière de correction et le détecteur d'onde acoustique sont disposés dans le même plan que la surface d'émission lumineuse et la surface de détection d'onde acoustique.
3. Sonde selon la revendication 1 ou 2, dans laquelle le détecteur d'onde acoustique inclut une pluralité d'éléments de détecteur agencés le long d'une direction.
4. Sonde selon la revendication 3, dans laquelle une pluralité des unités émettant une lumière de mesure sont prévues, et la pluralité d'unités émettant une lumière de mesure sont les unes 55

en face des autres, le détecteur d'onde acoustique étant interposé entre elles dans une direction perpendiculaire à la une direction, et la source de lumière de correction et le détecteur d'intensité lumineuse sont disposés entre l'unité émettant une lumière de mesure et le détecteur d'onde acoustique.

5. Sonde selon la revendication 3 ou 4, dans laquelle la source de lumière de correction inclut une première source de lumière de correction, laquelle est agencée le long de la une direction et est configurée pour émettre une première lumière de correction présentant une première longueur d'onde, et une seconde source de lumière de correction, laquelle est agencée le long de la une direction et émet une seconde lumière de correction présentant une seconde longueur d'onde, différente de la première longueur d'onde. 5 10
6. Sonde selon la revendication 5, dans laquelle la source de lumière de correction inclut une pluralité de premières sources de lumière de correction et une pluralité de secondes sources de lumière de correction. 15
7. Sonde selon la revendication 6, dans laquelle la pluralité de premières sources de lumière de correction et la pluralité de secondes sources de lumière de correction sont agencées par alternance le long de la une direction. 20
8. Sonde selon l'une quelconque des revendications 3 à 7, dans laquelle le détecteur d'intensité lumineuse inclut un premier détecteur d'intensité lumineuse, lequel est agencé le long de la une direction et est configuré pour détecter de manière sélective une lumière de correction présentant la première longueur d'onde, et un second détecteur d'intensité lumineuse, lequel est agencé le long de la une direction et est configuré pour détecter de manière sélective une lumière de correction présentant la seconde longueur d'onde. 25 30 35 40 45
9. Sonde selon la revendication 8, dans laquelle le premier détecteur d'intensité lumineuse inclut un premier filtre optique configuré pour transmettre une lumière présentant la première longueur d'onde et pour ne pas transmettre de lumière présentant la seconde longueur d'onde, et le second détecteur d'intensité lumineuse inclut un second filtre optique configuré pour transmettre une lumière présentant la seconde longueur d'onde et pour ne pas transmettre de lumière présentant la première longueur d'onde. 50
10. Sonde selon la revendication 8 ou 9,

dans laquelle le détecteur d'intensité lumineuse inclut une pluralité des premiers détecteurs d'intensité lumineuse et une pluralité des seconds détecteurs d'intensité lumineuse.

11. Sonde selon la revendication 10, dans laquelle la pluralité de premiers détecteurs d'intensité lumineuse et la pluralité de seconds détecteurs d'intensité lumineuse sont agencées par alternance le long de la une direction.
12. Sonde selon l'une quelconque des revendications 1 à 11, dans laquelle une longueur d'onde de la lumière de mesure et une longueur d'onde de la lumière de correction sont différentes l'une de l'autre, et le détecteur d'intensité lumineuse est en outre configuré pour détecter une lumière réfléchie, générée par la réflexion de la lumière de mesure, laquelle est émise vers le sujet, à partir du sujet.
13. Sonde selon l'une quelconque des revendications 1 à 12, dans laquelle la source de lumière de correction inclut une diode électroluminescente.
14. Appareil de mesure photoacoustique, comprenant : la sonde selon l'une quelconque des revendications 1 à 13, une source lumineuse configurée pour émettre la lumière de mesure, et un dispositif de traitement de signaux, lequel présente une unité de traitement de signaux configurée pour exécuter un traitement de signaux sur la base d'un signal de détection de l'onde photoacoustique détectée par le détecteur d'onde acoustique, une unité d'estimation de quantité de mélanine, laquelle estime une quantité de mélanine sur la base d'un signal de détection de la lumière réfléchie détectée par le détecteur d'intensité lumineuse, et une unité de correction configurée pour corriger le traitement de signaux de l'unité de traitement de signaux.
15. Appareil de mesure photoacoustique selon la revendication 14, dans lequel l'unité de traitement de signaux est configurée pour générer une image photoacoustique sur la base du signal de détection de l'onde photoacoustique.
16. Appareil de mesure photoacoustique selon la revendication 14 ou 15, dans lequel la sonde est la sonde selon l'une quelconque des revendications 5 à 11, et l'unité d'estimation de quantité de mélanine est configurée pour estimer la quantité de mélanine sur la

base d'un signal de détection de lumière réfléchi
de la première lumière de correction détectée par le
détecteur d'intensité lumineuse, et d'un signal de dé-
tection de lumière réfléchi de la seconde lumière
de correction détectée par le détecteur d'intensité
lumineuse. 5

17. Appareil de mesure photoacoustique selon la reven-
dication 14 ou 15,
dans lequel la sonde est la sonde selon la revendi- 10
cation 12, et
l'unité d'estimation de quantité de mélanine est con-
figurée pour estimer la quantité de mélanine sur la
base d'un signal de détection de lumière réfléchi
de la lumière de correction détectée par le détecteur 15
d'intensité lumineuse, et d'un signal de détection de
lumière réfléchi de la lumière de mesure détectée
par le détecteur d'intensité lumineuse.

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FIG. 1

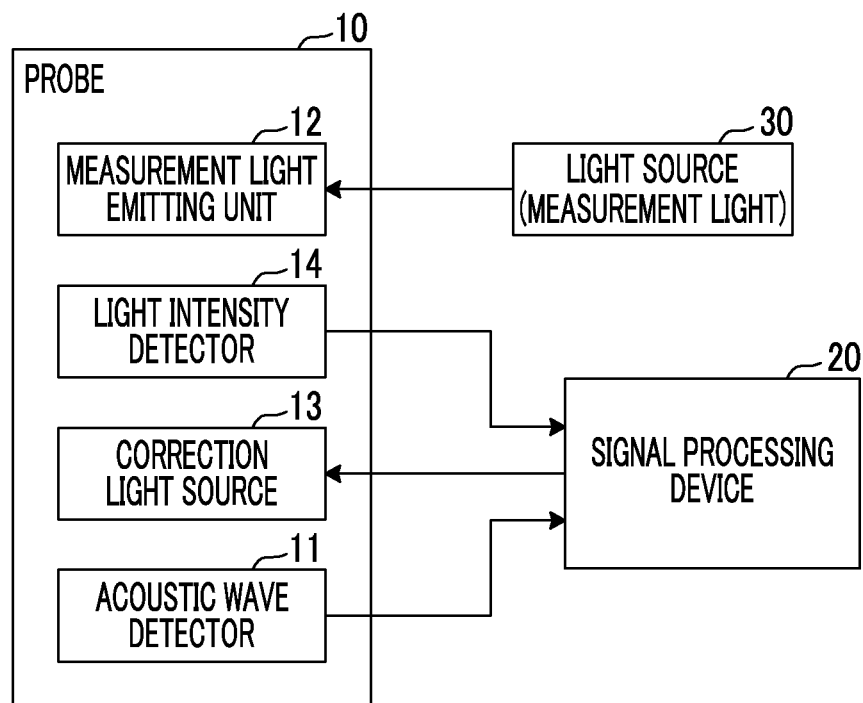


FIG. 2

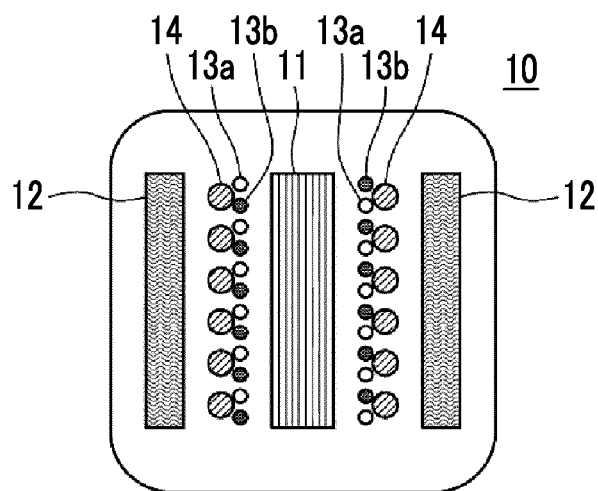


FIG. 3

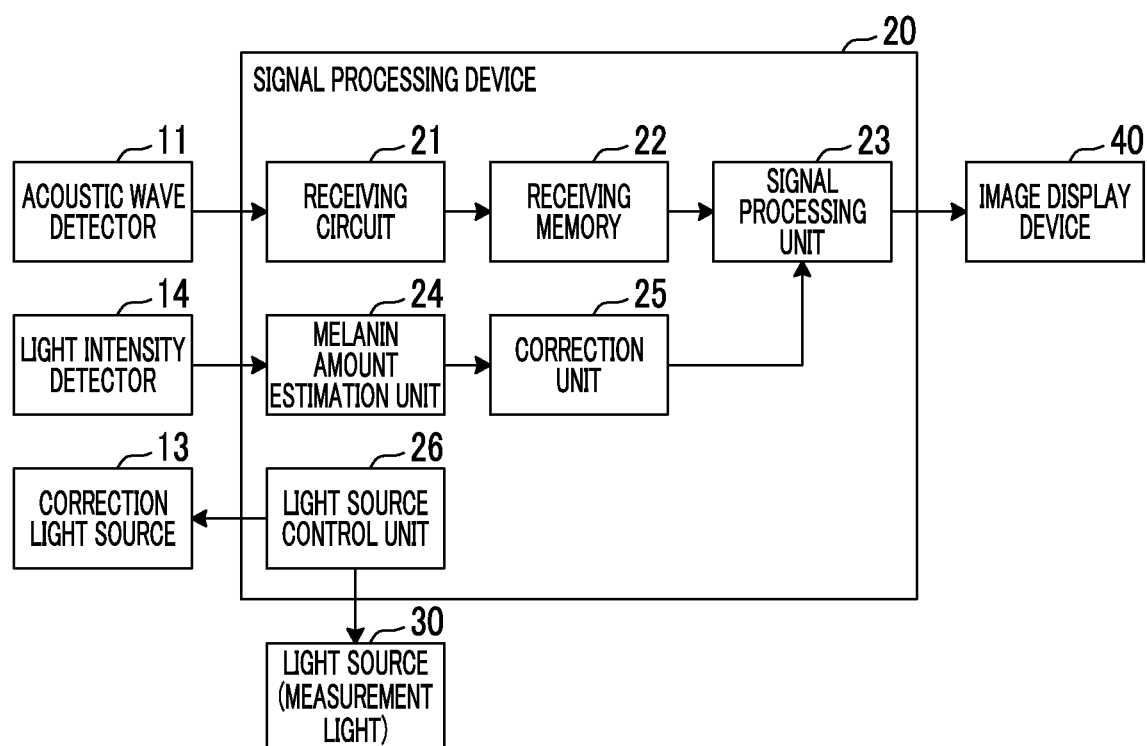


FIG. 4

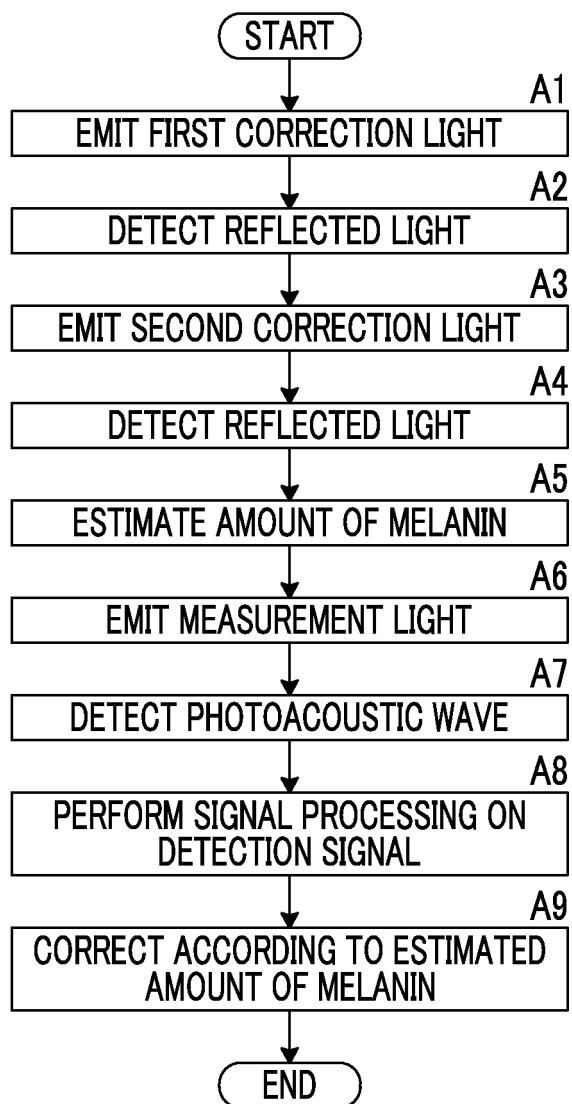


FIG. 5

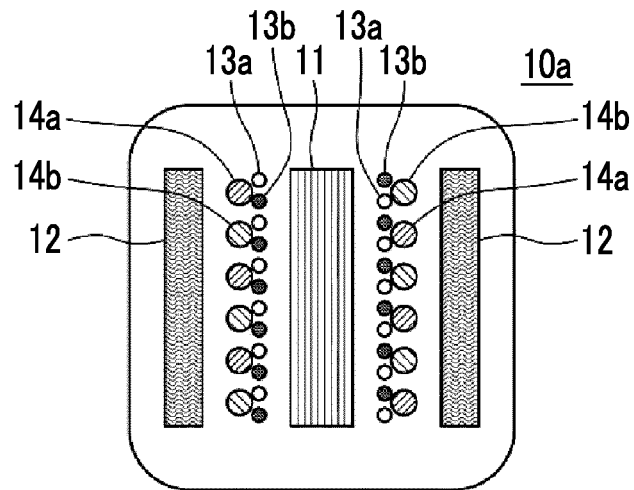


FIG. 6

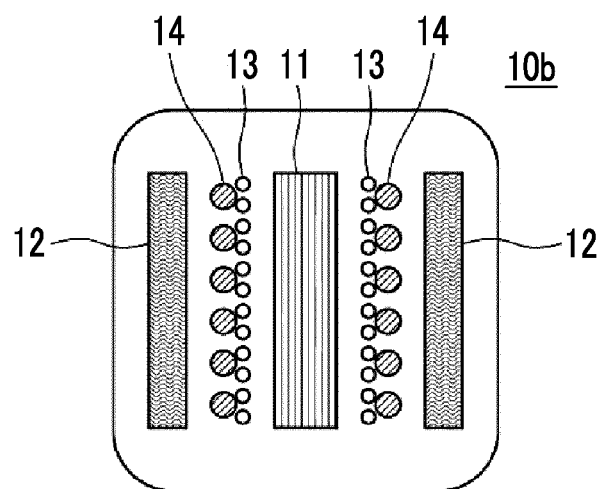
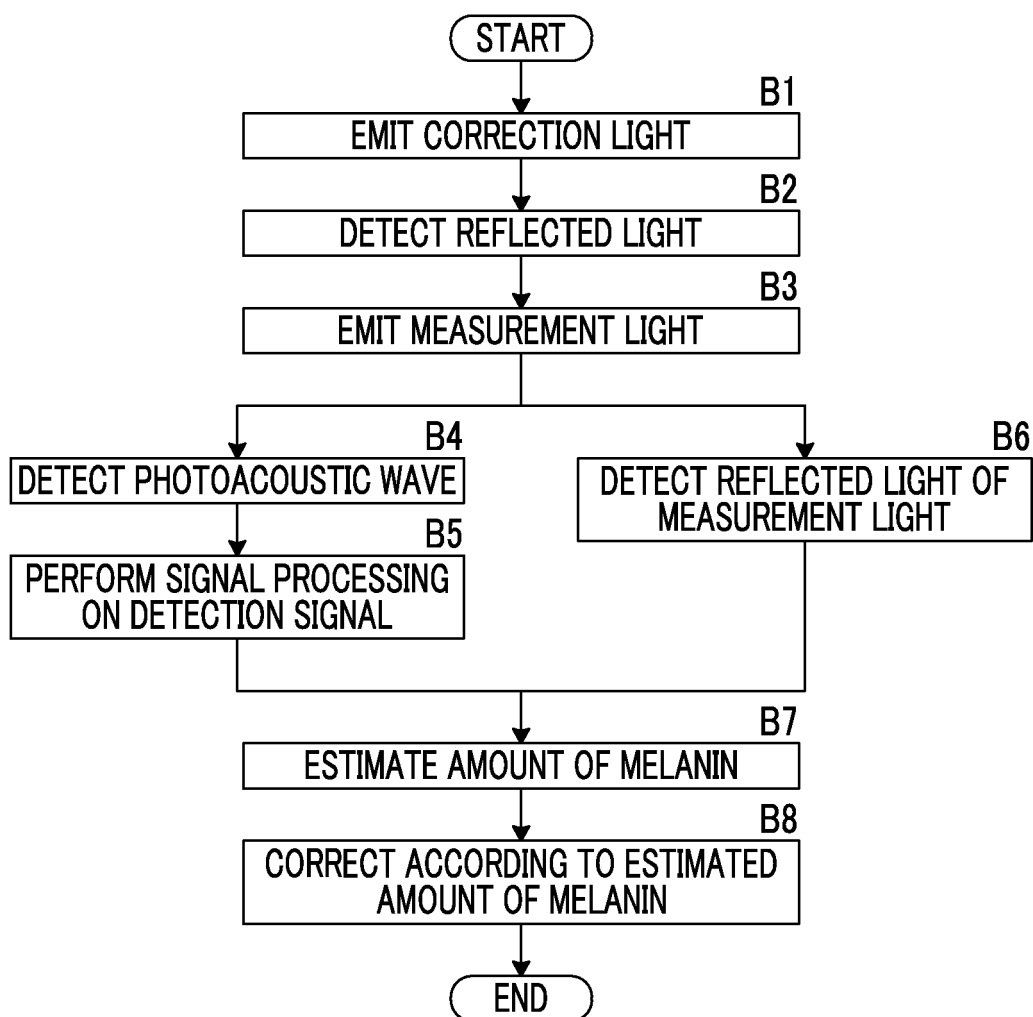


FIG. 7



REFERENCES CITED IN THE DESCRIPTION

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Patent documents cited in the description

- JP 2013055988 A [0005] [0007] [0052]
- US 2013160557 A1 [0006]

专利名称(译)	光声测量装置和探头		
公开(公告)号	EP3269309B1	公开(公告)日	2018-12-12
申请号	EP2016764537	申请日	2016-01-28
[标]申请(专利权)人(译)	富士胶片株式会社		
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优先权	2015050403 2015-03-13 JP		
其他公开文献	EP3269309A1 EP3269309A4		
外部链接	Espacenet		

摘要(译)

在光声测量设备和探头中，减少了由于在对象的表面部分中产生的光声波引起的伪像，而不增加光声测量的重复周期。测量发光单元12向对象发射测量光。声波检测器11检测由于测量光而在对象内产生的光声波。校正光源13向对象发射校正光。光强度检测器14检测由对象发射的朝向对象发射的校正光的反射所产生的反射光。在探头10中，校正光源13和光强度检测器14设置在测量光发射单元12和声波检测器11之间。

FIG. 1

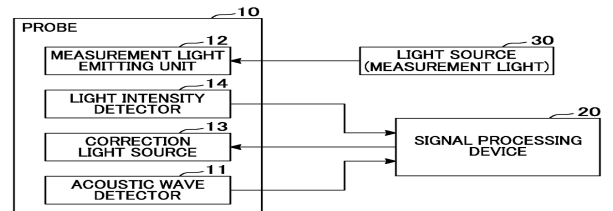


FIG. 2

